

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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Title of Invention

IMPROVED TOP-OXIDE-EARLY PROCESSAND ARRAY TOP
OXIDE PLANARIZATION

Application Number :

Confirmation Number:

First Named Applicant: Deok-kee Kim

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Art Unit:

Examiner:

Search string: (6617245 or 6620677 or 6429068 or 6709924 or 6716764 or 6124165 or 6103623 or 6403494 or 5883006 or 6103623 or 5895946 or 6576526 or 5780339 or 6100138 or 6165839 or 6730980 or 6673686 or 6617213 or 6509226 or 20030186502 or 20040033659 or 20040075111 or 20030143809).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6617245	2003-09-09	Ueda			
	2	6620677	2003-09-16	Hummler			
	3	6429068	2002-08-06	Divakaruni et al.			
	4	6709924	2004-03-23	Yu et al.			
	5	6716764	2004-04-06	Girard et al.			
	6	6124165	2000-09-26	Lien			
	7	6103623	2000-08-15	Lien et al.			
	8	6403494	2002-06-11	Chu et al.			
	9	5883006	1999-03-16	Iba			
	10	6103623	2000-08-15	Lien et al.			
	11	5895946	1999-04-20	Hamamoto et al.			
	12	6576526	2003-06-10	Kai et al.			
	13	5780339	1998-07-14	Liu et al.			
	14	6100138	2000-08-08	Tu			
	15	6165839	2000-12-26	Lee et al.			
	16	6730980	2004-05-04	Rhodes			
	17	6673686	2004-01-06	Scholz et al.			
	18	6617213	2003-09-09	Hummler			
	19	6509226	2003-01-21	Jaiprakash et al.			

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20030186502	2003-10-02	Malik et al.			
	2	20040033659	2004-02-19	Seitz et al.			
	3	20040075111	2004-04-22	Chidambarao et al.			
	4	20030143809	2003-07-31	Hummler			

Signature

Examiner Name	Date